	Application No.	A == (!= == 4/=)
	Application No.	Applicant(s)
Notice of Allowability	10/728,903	ISHIKAWA, AKIRA
	Examiner	Art Unit
	Tuan Quach	2826
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS I herewith (or previously mailed), a Notice of Allowance (PTOL-8: NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT of the Office or upon petition by the applicant. See 37 CFR 1.3	S (OR REMAINS) CLOSED i 5) or other appropriate comm RIGHTS. This application is	n this application. If not included unication will be mailed in due course. THIS
1. This communication is responsive to <u>response filed July</u>	<u>28, 2005</u> .	
2. The allowed claim(s) is/are <u>56-72</u> .		
3. \boxtimes The drawings filed on <u>08 December 2003</u> are accepted by	y the Examiner.	
 4. Acknowledgment is made of a claim for foreign priority and an law and an analysis. a) All b) Some* c) None of the: Certified copies of the priority documents have a copies. Certified copies of the priority documents have a copies of the priority documents. Copies of the certified copies of the priority documents. International Bureau (PCT Rule 17.2(a)). 	ve been received. ve been received in Applicati	on No. <u>09/951,384</u> .
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE noted below. Failure to timely comply will result in ABANDON THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	" of this communication to file MENT of this application.	e a reply complying with the requirements
5. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.		
6. ☐ CORRECTED DRAWINGS (as "replacement sheets") more (a) ☐ including changes required by the Notice of Draftspe		w(PTO-948) attached
1) hereto or 2) to Paper No./Mail Date		
(b) including changes required by the attached Examine Paper No./Mail Date	r's Amendment / Comment o	r in the Office action of
Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in		
7. DEPOSIT OF and/or INFORMATION about the dep attached Examiner's comment regarding REQUIREMENT		
Attachment(s) 1. ☑ Notice of References Cited (PTO-892)	5. ☐ Notice of Ir	nformal Patent Application (PTO-152)
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	A 	summary (PTO-413),
3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB	Paper No.	/Mail Date Amendment/Comment
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit		Statement of Reasons for Allowance
of Biological Material	9. 🔲 Other	
•		_
		Tuan Quach Primary Examiner

EXAMINER'S AMENDMENT AND REASONS FOR ALLOWANCE

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

This application is in condition for allowance except for the presence of claims 73-92 to an invention non-elected without traverse. Accordingly, claims 73-92 have been cancelled.

The following obvious informality is corrected regarding a typing error.

In claim 61 line 26, "the first tin film device" is changed to - - the first thin film device - -.

The following is an examiner's statement of reasons for allowance:

Claims 56-72 are allowed primarily because the prior art of record singly or in combination does not teach or suggest the combination to meet all the claimed limitations in the claimed inventions as delineated in claims 56, 61, and 67. In particular the prior art does not teach with regard to claims 56 the following limitations, taken in the context of the remaining limitations of the claim, concerning the third insulating over the second insulating film, the wiring, and the electrode, forming a third contact hole for reach the electrode in the third insulating film bonding a second substrate to a surface of the third insulating film; removing the first substrate; forming a fourth contact hole for reaching the first thin film transistor in the first insulating film, forming a second electrode on the

fist insulating film wherein the second electrode is connected to the first thin film transistor through the fourth contact hole; forming a fourth insulating film over the first insulating film and the second electrode, and forming a fifth contact hole for reaching the second electrode in the fourth insulating film and removing the substrate. The prior art also does not teach or suggest with regard to claims 61 and 67 the following limitations in the context of the remaining features in the claims, as delineated with regard to claim 56 above, and further including bonding the first thin film device to the second thin film device so that the fifth contact hole is opposed to the third contact hole wherein a conductive connection is made as in claim 61 the last four lines; or further including bonding the first thin film device to the second thin film so that the fifth contact hole is opposed to the third contact hole and bonding the third thin film device to the second thin film device so that the third contact hole is opposed to the fifth contact hole wherein a conductive connection is made as claimed in claim 67 the last seven lines.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to examiner Tuan Quach whose telephone number is 571-272-1717. The examiner can normally be reached on M-F from 8:30 AM to 4:30 PM.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor Nathan Flynn, can be reached on 571-272-1915. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Tuan Quach
Primary Examiner